

Contents

Part I Solution Chemistry

1 Simple Alkoxide Based Precursor Systems	3
Theodor Schneller	
2 Carboxylate Based Precursor Systems	29
Theodor Schneller and David Griesche	
3 Mixed Metallo-organic Precursor Systems	51
Barbara Malič, Sebastjan Glinšek, Theodor Schneller, and Marija Kosec	
4 Single Source Precursor Approach	71
Vadim G. Kessler	
5 Aqueous Precursor Systems	93
Marlies K. Van Bael, An Hardy, and Jules Mullens	
6 Polymer-Assisted Deposition	141
Anthony K. Burrell, Thomas M. McCleskey, and Quanxi Jia	

Part II Analytical Methods

7 Thermal Analysis	163
Barbara Malič, Alja Kupec, and Marija Kosec	
8 X-Ray Absorption Spectroscopy	181
Irene Schlipf, Matthias Bauer, and Helmut Bertagnolli	
9 Infrared Spectroscopy	213
Maria Zaharescu and Oana Cătălina Mocioiu	

Part III Deposition Techniques

- | | |
|--|-----|
| 10 Dip Coating | 233 |
| C. Jeffrey Brinker | |
| 11 Spin Coating: Art and Science | 263 |
| Dunbar P. Birnie III | |
| 12 Aerosol Deposition | 275 |
| Matt D. Brubaker | |
| 13 Inkjet Printing and Other Direct Writing Methods | 303 |
| Paul G. Clem and Nelson S. Bell | |
| 14 Chemical Bath Deposition | 319 |
| Mark R. De Guire, Luciana Pitta Bauermann, Harshil Parikh,
and Joachim Bill | |

Part IV Processing and Crystallization

- | | |
|---|-----|
| 15 Thermodynamics and Heating Processes | 343 |
| Robert W. Schwartz and Manoj Narayanan | |
| 16 Epitaxial Films | 383 |
| Fred Lange | |
| 17 Orientation and Microstructure Design | 407 |
| Susanne Hoffmann-Eifert and Theodor Schneller | |
| 18 Low-Temperature Processing | 431 |
| Sebastjan Glinšek, Barbara Malič, and Marija Kosec | |
| 19 Composite Film Processing | 445 |
| Robert Dorey, Subhasis Roy, A. Sharma, Chandan Ghanty,
and Subhasish B. Majumder | |
| 20 UV and E-Beam Direct Patterning of Photosensitive CSD Films . . . | 483 |
| Kiyoharu Tadanaga and Mohammad S.M. Saifullah | |
| 21 Template Controlled Growth | 517 |
| Sven Clemens and Theodor Schneller | |

Part V Functions and Applications

- | | |
|---|-----|
| 22 Thin Film Multilayer Capacitors | 547 |
| Hiroyuki Kambara, Theodor Schneller, and Rainer Waser | |
| 23 Base Metal Bottom Electrodes | 571 |
| Jon F. Ihlefeld, Mark D. Losego, and Jon-Paul Maria | |

24 Polar Oxide Thin Films for MEMS Applications	593
Paul Muralt	
25 Conducting Oxide Thin Films	621
Camilla Haavik and Per Martin Rørvik	
26 Transparent Conducting Oxides	655
Peer Löbmann	
27 Superconducting Films	673
Michael Bäcker, Martina Falter, Oliver Brunkahl, and Bernhard Holzapfel	
28 Antireflective Coatings and Optical Filters	707
Peer Löbmann	
29 Luminescent Thin Films: Fundamental Aspects and Practical Applications	725
Shinobu Fujihara	
Appendix A: Syntheses	747
Index	773